

#### LA-UR-19-23298

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Title: X-ray detector development at 100 MHz framerate or above

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Intended for: Discussion at DESY on LANL-HIBEF collaboration

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### X-ray detector development

#### At 100 MHz framerate or above

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Eu-XFEL/DESY, Hamburg, DE







#### Introduction to the challenges

- MaRIE workshops and community wisdoms
- The state-of-the-art
- **Opportunities**

### Our approach & progress (enabled by collaborations)

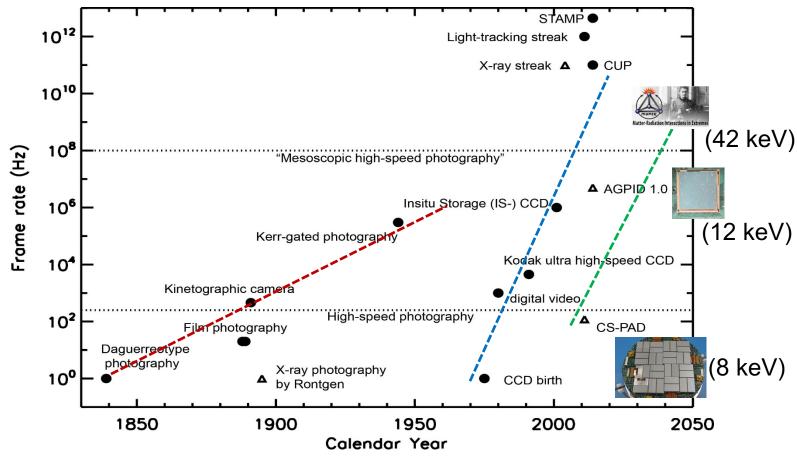
- **New Materials** 
  - **Materials Discovery**
- New Architectures
  - Pushing silicon architecture to higher speeds
- New data & imaging methods
- Near term applications Laboratory and APS Experimental tests of materials and imaging

#### **Upcoming activities**

- Development and experimental validation where vision and support coincide
- ULITIMA 2020 (jointly with ICHSIP33 ~ San Diego, CA, USA)



## **Evolution of high-speed imaging technologies**





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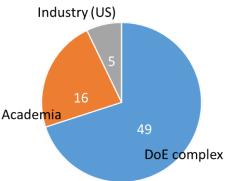
## The August 2016 workshop surveyed current status And identified future opportunities

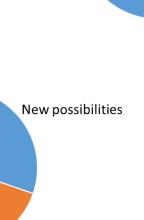


Data software & hardware (ASIC)

Experiments &

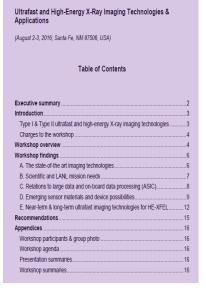
**Applications** 





State-of-the-art







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## Two-pronged development process: (Low & High Risk)

Performance	Type I imager	Type II imager
X-ray energy	30 keV	42-126 keV
Frame-rate/inter-frame time	0.5 GHz/2 ns	3 GHz / 300 ps
Number of frames	10	10 - 30
X-ray detection efficiency	above 50%	above 80%
Pixel size/pitch	≤ 300 mm	< 300 mm
Dynamic range	10 <sup>3</sup> X-ray photons	≥ 10 <sup>4</sup> X-ray photons
Pixel format	64 x 64 (scalable to 1 Mpix)	1 Mpix

#### MaRIE KPP requirements

ASIC/Data	No. Chan.	Analog bandwidth (GHz)	digital samplin g (GHz)	S/N (dB)	Bit Res.	CMOS technol.		
PSEC4	6	1.5	15		10.5	IBM 130 nm		
"Hawaii	128?	3	20	58 dB/	9.4	(TSMC 130 nm)		
chip"				1Vpp				
"Cornell	384 x	0.5						
Keck GHz"	256							
epix∆	1M	3			>= 8	TSMC 250 nm		



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## Analysis of current performance gaps to requirements points to speed and high-energy efficiency as critical issues

	(>50%) x (>20 keV)	Sensor Speed (<10 ns)	ASIC (>0.1 GHz)	No. of Frames (>10)	Resolution (<250 μm)	Dynamic Range (> 10³)
UXI	< 100 μm Si	-	~ 0.5 GHz	4	25 μm	-
pRad2	< 100 μm Si	50 ns	4 MHz	10	40 μm	<10 <sup>3</sup>
AGIPD 1.0	500 μm Si	> 10 ns	4.5 MHz	352	200 μm	104
KeckPAD	500 μm Si	> 10 ns	6.5 MHz	8	150 μm	> 10³
ePix100a	500 μm Si	> 10ns	120 Hz	1	25 μm	>10³
EIGER	450 μm Si	> 10 ns	9 kHz	1	75 μm	> 10³
Ultra UBSi	< 100 μm Si	-	1 GHz	25	7.4 μm	<10³
Teledyne Dalsa	< 100 μm Si	•	100 MHz	16	< 50 μm	-



(Credit: C. W. Barnes)

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## **Our vision**

\* Involve materials scientists to develop new photon conversion materials "GHz technology"

Explore new architectures, work with a national collaboration

"100 MHz + technology"

Data-method boosted hardware development & performance

"10 MHz technology "

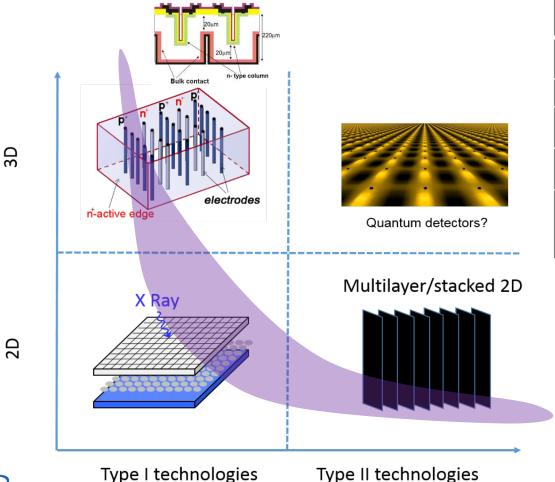
We are here



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# 1) There are Structural & Processing Innovations that could be pursued



Material Processes	Features
Thin film process	novel thin-film properties
Additive process	Micro-, nano-grains
Microfluidic process	Versatile nano- particle assembly
Polymer-assisted fabrication	Versatile nano- particle assembly
Self- assembly/biological assisted processes	Autonomous

Existing processes: CMOS, SOI, SiGe.

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## MULTI-LAB (NNSA and DOE/SC) TEAM on advancing silicon

#### ANL

- SYNCHROTRON SOURCE (APS)
- MONOLITHIC DETECTOR TECHNOLOGY (MAPS); MCP & photodetectors benchmark



#### LANL

- SYSTEM INTEGRATION, NOVEL STRUCTURES
- TESTING & APPLICATIONS (IMAGING METHODS, DATA Handling)

#### LBL

ULTRFAST PHOTODETECTORS

#### SNL

CHIPs/ROICs, DESIGNs



~\$20M TPC over 5 years to deliver 100 MHz framing camera for use at DCS@APS or LCLS

#### SLAC

LCLS & OTHER FACILITIES

ASIC DESIGNs, HYBRID CONCEPTS



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## **UMA** collaboration













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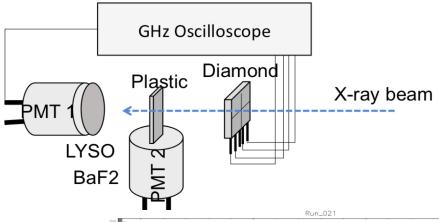
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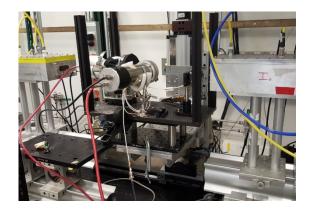


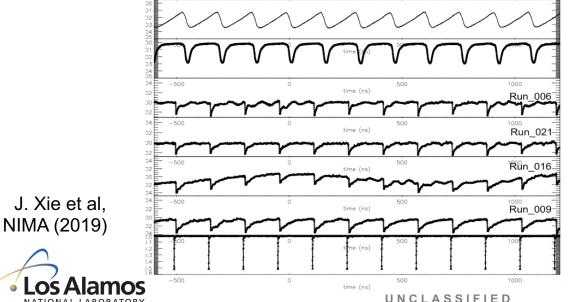




## **APS Experiment (Feb. 2018)**







LYSO + PMT 1 Fast plastic + PMT 2

Diamond (Quadrant A)

Diamond (Quadrant B)

Diamond (Quadrant C)

Diamond (Quadrant D)

APS timing pulses

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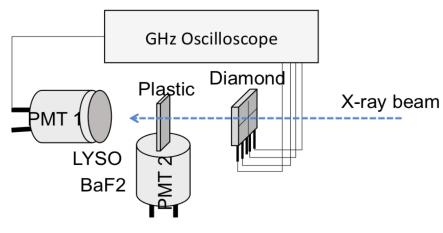
## **APS Experiment (Jul. 2018)**

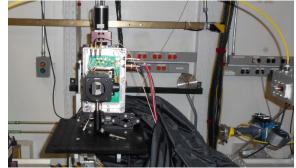


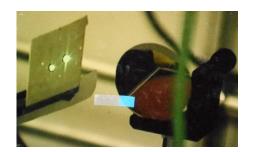














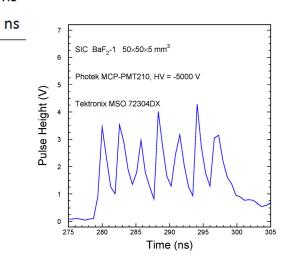
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## 12 fast Scintillators tested

			De	Detector		LYSO+PMT1		Plastic+PMT2		2	Diamond		
			Amplitude		20.9 ± 0.4 mV		25.8 ± 0.4 mV		V 1	1.9 ± 0.2 mV			
		D-5	Rise time Decay time		18.4 ± 0.6 ns		12.4 ± 0.2 ns		5 2	2.0 ± 0.2 ns			
	BaF <sub>2</sub>	BaF <sub>2</sub> (:Y)			80.7 ± 1.8 ns		26.7 ± 0.9 ns		s 2	28.3± 6.2 ns			
Density (g/cm <sup>3</sup> )	4.89	4.89											
Melting points (°C)	1280	1280	1975	1870	1940	1725	2050	2060	1870	1850	1930	2070	
X <sub>0</sub> (cm)	2.03	2.03	2.51	2.77	3.53	2.51	1.14	1.45	2.77	1.63	1.37	3.10	
R <sub>M</sub> (cm)	3.1	3.1	2.28	2.4	2.76	2.20	2.07	2.15	2.4	2.20	2.01	2.93	
λ <sub>I</sub> (cm)	30.7	30.7	22.2	22.4	25.2	20.9	20.9	20.6	22.4	21.5	19.5	27.8	
<b>Z</b> <sub>eff</sub>	51.6	51.6	27.7	31.9	30	28.1	64.8	60.3	31.9	51.8	58.6	33.3	
dE/dX (MeV/cm)	6.52	6.52	8.42	8.05	7.01	8.82	9.55	9.22	8.05	8.96	9.82	6.57	
λ <sub>peak</sub> a (nm)	300 220	300 220	380	350	350	380	420	520	370	540	385	420	
Refractive Index <sup>b</sup>	1.50	1.50	2.1	1.96	1.87	1.97	1.82	1.84	1.96	1.92	1.94	1.78	
Normalized Light Yield <sup>a,c</sup>	42 4.8	1.7 4.8	6.6 <sup>d</sup>	0.19 <sup>d</sup>	0.36 <sup>d</sup>	6.5 0.5	100	35 <sup>e</sup> 48 <sup>e</sup>	9 32	115	16 15	80	
Total Light yield (ph/MeV)	13,000	2,000	2,000 <sup>d</sup>	57 <sup>d</sup>	110 <sup>d</sup>	2,100	30,000	25,000°	12,000	34,400	10,000	24,000	
Decay time <sup>a</sup> (ns)	600 0.6	600 0.6	<1	1.5	4	148 6	40	820 50	191 25	53	1485 36	75	
LY in 1 <sup>st</sup> ns (photons/MeV)	1200	1200	610 <sup>d</sup>	28 <sup>d</sup>	24 <sup>d</sup>	43	740	240	391	640	125	318	
40 keV Att. Leng. (1/e, mm)	0.106	0.106	0.407	0.314	0.439	0.394	0.185	0.251	0.314	0.319	0.214	0.334	

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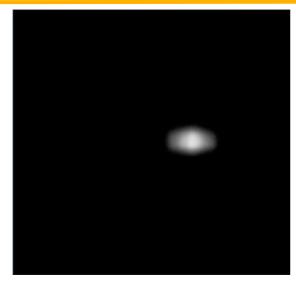


Hybrid mode 2.83 ns bunch spacing



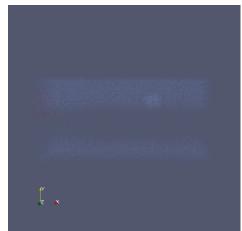
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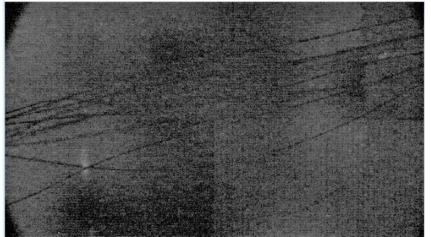
## High-energy X-ray Ghost imaging (preliminary)



Primary beam







(< 20 um possible)

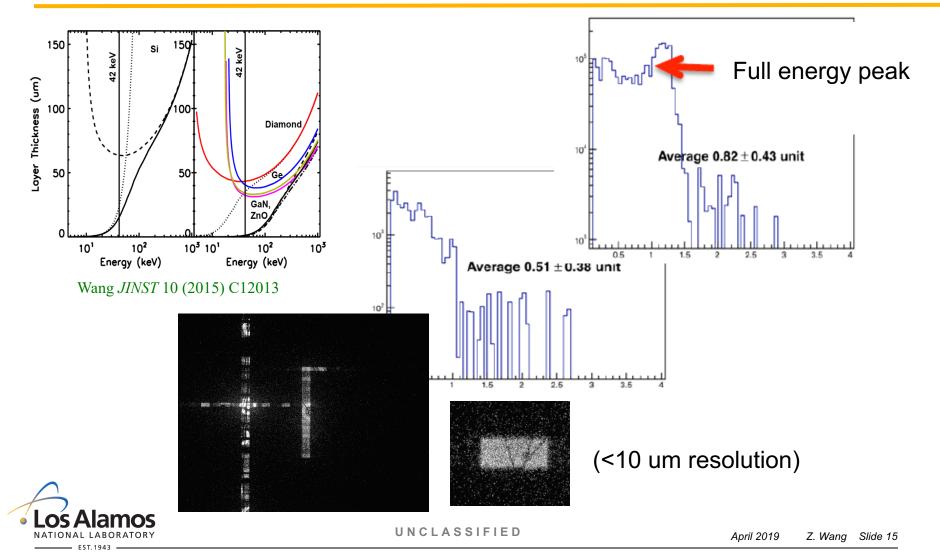


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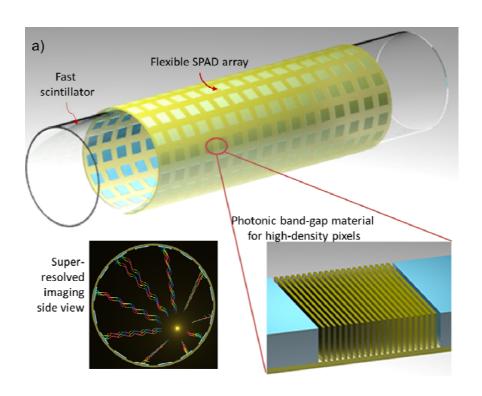


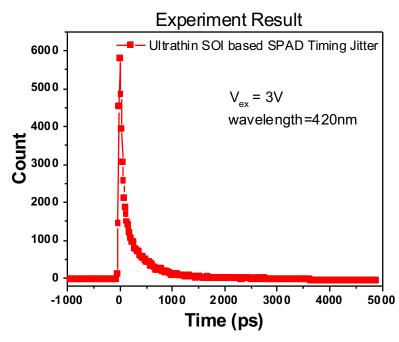
## Silicon camera characterization



## SSAP collaboration —Univ. Wisconsin Madison



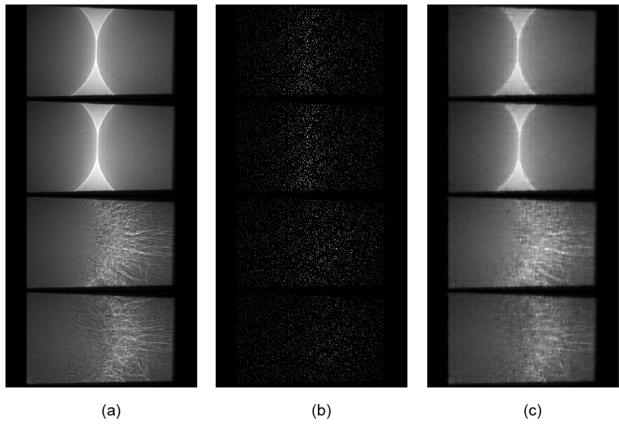






# 3) New data methods like Sparse X-ray imaging can make good images with fewer photons

Wang et al, JINST 13 (2018) C01035





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## $UMA \rightarrow UDA$ collaboration





















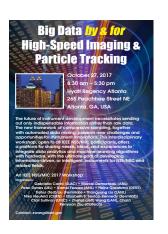
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## We continue to interact, learn from, and collaborate with the best detector teams in the world







ULITIMA2020 + ICHSIP33





### **Acknowledgement**



J. Bohon



O. laroshenko



X. Li



Y. Sechrest



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**BoD DEC 2014** 

## **Summary**

- Ultrafast imaging technology development requires interdisciplinary approach
- Data methods can potentially accelerate the development of ultrafast high-energy X-ray imaging technology
  - For data & by Data
- A multi-institution & multi-disciplinary team in place
  - New collaborations in hardware & applications welcome!

